

Form PTO-1449		DEC 08 2003		Docket No.: 10013.0001US		Applicant: XU et al.	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION <small>(Use separate sheets if necessary)</small>				Filing Date: October 1, 2003		Group Art Unit: NA 3746	
U. S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
MK ↓ ↓ ↓ ↓ ↓	5,499,909	3/19/96	Yamada et al.	417	384		
	5,759,014	6/2/98	Van Lintel	417	413.3		
	6,390,791	5/21/02	Maillefer et al.	417	413.3		
	6,408,878	6/25/02	Unger et al.	137	597		
	6,520,753	2/18/03	Grosjean et al.	417	379		
	2002/0081866 A1	6/27/02	Choi et al.	438	800		
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
MK	02/43615	6/6/02	WO				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
MK ↓ ↓ ↓ ↓ ↓	AA	Maillefer, D. et al., "A high-performance silicon micropump for disposable drug delivery systems", The thirteenth IEEE International Micro Electro Mechanical Systems (MEMS-2000 Conference, Miyazaki, Japan, 413-417					
	AB	Khoo, M. et al., "A novel micromachined magnetic membrane microfluid pump", The 22nd Annual International Conference of the IEEE Engineering in Medicine and Biology Society. Chicago, IL, 2000, 1-4.					
	AC	Linnemann, R. et al., "A self-priming and bubble-tolerant piezoelectric silicon micropump for liquids and gases", The 11th annual international workshop on MEMS, 1998 Heidelberg Germany, 532-537.					
	AD	Kamper, K.P. et al., "A self-filling low-cost membrane micropump", The 11th annual international workshop on MEMS, 1998 Heidelberg Germany, 432-437.					
	AE	Shinohara, J. et al., "A high pressure-resistance micropump using active and normally-closed valves", Thirteenth IEEE International Micro Electro Mechanical Systems (MEMS-2000) Conference, Miyazaki, Japan, 2000.					
	AF	Grosjean, C. et al., "A thermopneumatic peristaltic micropump", Technical Digest of Transducers '99, Sendai, Japan.					
↓	AG	Maillefer, D. et al., "A high-performance silicon micropump for an implantable drug delivery system", The 1999 IEEE International Micro Electro Mechanical Systems (MEMS-1999) Conference. Orlando, FL, 1999.					
	AH						
EXAMINER /Michael Koczko Jr/				DATE CONSIDERED 12/26/2006			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							

Sheet 1 of 1

Form PTO-1449		Docket No.: 10013.0001US		Application No.: 10/876,601		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)		Applicant: XU et al.		Filing Date: October 1, 2003		
		Group Art Unit: 3746				
U. S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FLING DATE IF APPROPRIATE
MK V	5,219,278	6/15/93	van Lintel	417	413	
	5,725,363	3/10/98	Bustgens et al.	417	413.1	
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
MK V	2248891	4/22/92	GB			
	0789146	8/13/97	EP			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
MK	AH	International Search Report for International Application No. PCT/SG2004/000314, which claims priority to the above identified application, and dated November 26, 2004.				
	AI					
	AJ					
	AK					
	AL					
	AM					
	AN					
	AO					
EXAMINER /Michael Koczko Jr/			DATE CONSIDERED 12/26/2006			
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